

S/N 09/652,713

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Trung T. Doan	Examiner:	Sylvia MacArthur
Serial No.:	09/652,713	Group Art Unit:	1763
Filed:	August 31, 2000	Docket:	303.928US5
Title:	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING		

**NOTICE OF APPEAL FROM THE DECISION OF THE EXAMINER
TO THE BOARD OF PATENT APPEALS AND INTERFERENCES**

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In compliance with 37 C.F.R. § 41.31(a)(1), Applicant hereby appeals to the Board of Patent Appeals and Interferences from the decision dated January 19, 2007, of the Examiner rejecting claims 36-45 of the above-identified patent application.

No extension of time is necessary to respond to the Examiner's rejection.

Please charge the amount of \$500.00 in payment of the Notice of Appeal fee under 37 C.F.R. § 41.20(b)(1), as well as any additional required fees, to Deposit Account No. 19-0743.

Respectfully submitted,

TRUNG T. DOAN

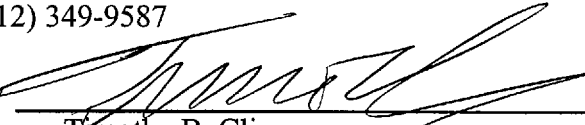
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Date

14 April '07

By



Timothy B. Clise
Reg. No. 40,957

I hereby certify that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 19 day of April 2007.

Name

Kate Cannon

Signature

